

	Application No.	Applicant(s)
Nation of Allowahility	10/787,449	NAKANO ET AL.
Notice of Allowability	Examiner	Art Unit
	Huedung X. Cao	2821
The MAILING DATE of this communication appeal claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this apport or other appropriate communication GHTS. This application is subject to	plication. If not included will be mailed in due course. THIS
1. X This communication is responsive to amendment, filed on 0	<u>07/27/05</u> .	
2. ☑ The allowed claim(s) is/are <u>1-8</u> .		
3. A The drawings filed on 25 February 2004 are accepted by the	ne Examiner.	
4. Acknowledgment is made of a claim for foreign priority una) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 5. A SUBSTITUTE OATH OR DECLARATION must be subminformal PATENT APPLICATION (PTO-152) which give (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Paper No./Mail Date (b) including changes required by the attached Examiner's Paper No./Mail Date (c) Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the Company of the paper No./Mail Date attached Examiner's comment regarding REQUIREMENT in the company of the priority documents and the depose attached Examiner's comment regarding REQUIREMENT in the company of the priority documents and the depose attached Examiner's comment regarding REQUIREMENT in the company of the priority documents and the company of the priority documents and the	e been received. been received in Application No cuments have been received in this of this communication to file a reply IENT of this application. itted. Note the attached EXAMINER as reason(s) why the oath or declara at be submitted. son's Patent Drawing Review (PTO- as Amendment / Comment or in the Comment or in the Comment of BIOLOGICAL MATERIAL resist of BIOLOGICAL MATERIAL resist of BIOLOGICAL MATERIAL resists of BIOLOGICAL materials and set the second resists of BIOLOGICAL MATERIAL resists of BIOLOGICAL MATERIAL resists of BIOLOGICAL materials and second resists and seco	complying with the requirements 'S AMENDMENT or NOTICE OF tion is deficient. 948) attached Office action of the back) of d). nust be submitted. Note the
Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. Interview Summary Paper No./Mail Dat Paper No./Mail Dat Examiner's Amendr 8. Examiner's Statem 9. Other	te

Examiner's Statement of Reasons for Allowance

1. Claims 1-8 are allowed.

2. The following is an examiner's statement of reasons for allowance:

The prior art made of record fails to anticipate or make obvious the claimed invention. Specifically, the prior art fails to teach, in combination with the remaining elements as recited in claim 1:

The present invention is directed to an antenna apparatus including a flat-plate radiation element and improved in radiation characteristic.

Regarding claim 1, Prior art teaches a feeding lead, a ground conductor, an antenna radiation element disposed on a front of a dielectric substrate. However; Prior art fails to specifically teach that a flat-plate radiation element buried inside the dielectric substrate at a center portion of the dielectric substrate; a side wall portion extending in a thickness direction of the radiation element such that the conductor cover covers all of the side surfaces of the dielectric substrate, and at least one hood portion extending from an upper edge of the side wall portion so as to cover a part of an upper surface of the dielectric substrate.

Claims 2-8 are allowed for depending on claim 1.

3. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Application/Control Number: 10/787,449

Art Unit: 2821

Inquiries

4. Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Huedung Cao whose telephone number is (571) 272-

1939.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Don Wong, can be reached on (571) 272-1834. The fax phone number for

571-273-8300 4-

Page 3

the organization where this application or proceeding is assigned is 703-872-9306.

5. Information regarding the status of an application may be obtained from the

Patent Application Information Retrieval (PAIR) system. Status information for

published applications may be obtained from either Private PAIR or Public PAIR.

Status information for unpublished applications is available through Private PAIR only.

For more information about the PAIR system, see http://pair-direct.uspto.gov. Should

you have questions on access to the Private PAIR system, contact the Electronic

Business Center (EBC) at 866-217-9197 (toll-free).

Huedung Cao

Patent Examiner

THUY V.TRAN